



DOCUMENT CHANGE REQUEST

DCR number 966 Changes required for: General
Date: 2016/01/15 Date sent: 2015/12/14
Status: IMPLEMENTED

Originator: Steve Thacker
Organisation: ESCC Executive Secretariat

Title: Microsection Examination Preparation and Evaluation of Capacitors Fixed Ceramic Leaded and

Number: 23400 Issue: 3

Other documents affected:

Page:

9

Paragraph:

4.4

Original wording:

3rd subpara:

The use of diamond lapping compounds is recommended having a maximum particle size of 9mm down to 3mm for rough polishing with smaller particle sizes being available for fine polishing.

Proposed wording:


change 'mm' to 'µm' (micrometre) in two places.

i.e.:

The use of diamond lapping compounds is recommended having a maximum particle size of 9µm down to 3µm for rough polishing with smaller particle sizes being available for fine polishing.

Justification:

typographical error in earlier spec revision.

Attachments:
N/A
Modifications:
N/A
Approval signature:

Date signed:
2016-01-15